

ASMJP.149AUS



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shinriki, et al.  
Appl. No. : 10/824,798  
Filed : April 15, 2004  
For : THIN-FILM DEPOSITION  
APPARATUS  
Examiner : Rudy Zervigon  
Group Art Unit : 1763

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 5, 2005

(Date)

  
Katsuhiro Arai, Reg. No. 43,315

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the communication from the Examiner mailed September 8, 2005. In response to the restriction requirement set forth in the communication, Applicant elects to prosecute Claims 1-20 and 30-40, drawn to a thin film deposition apparatus. This election is made without traverse.

No fees are believed due for the present Amendment, however, should any fees be due, please charge them to our deposit account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: October 5, 2005

By: 

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